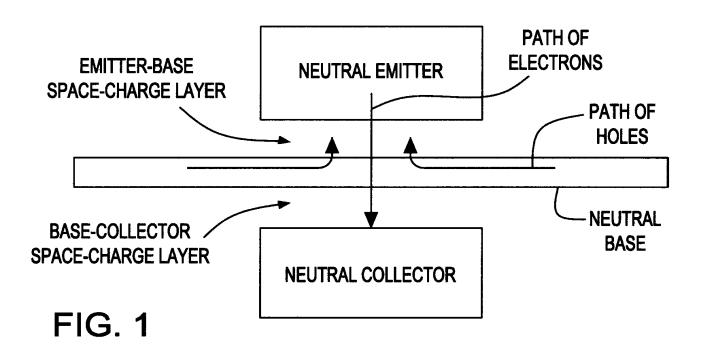
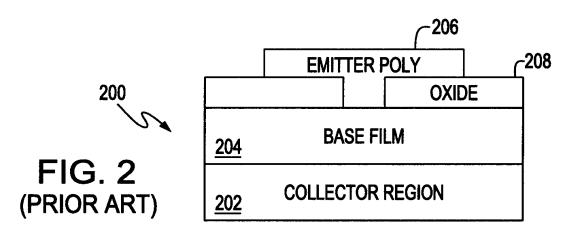
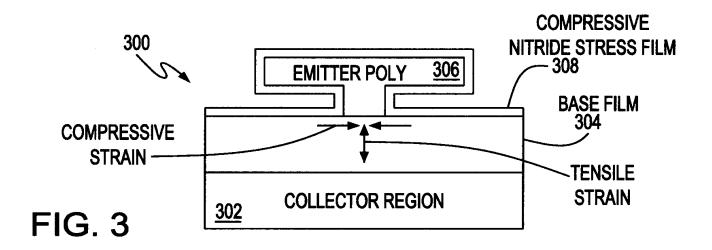
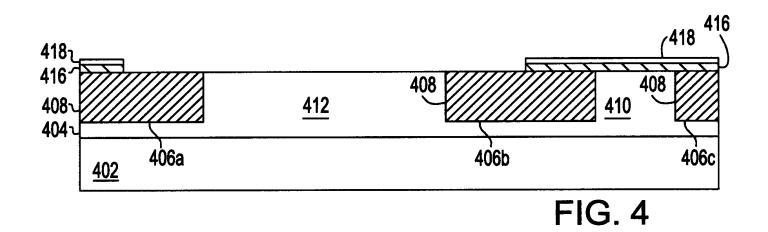
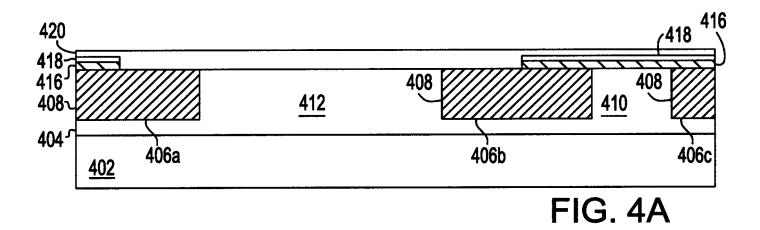
1/7 Chidambarrao, et al. FIS920040178US1 HDS

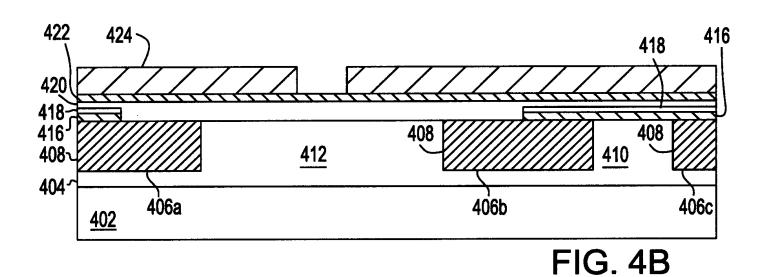


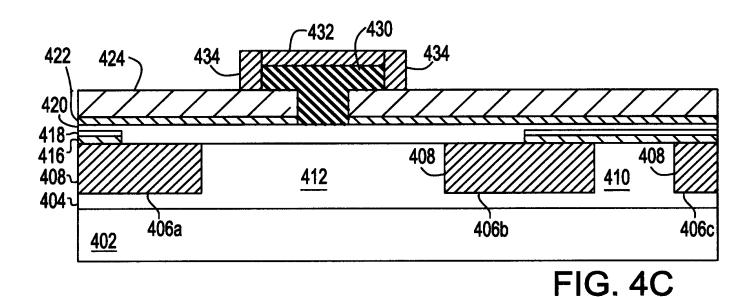


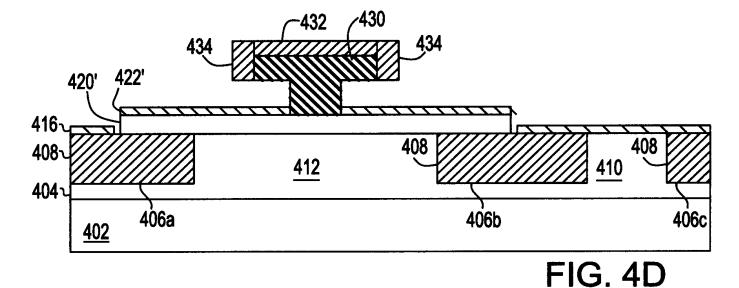












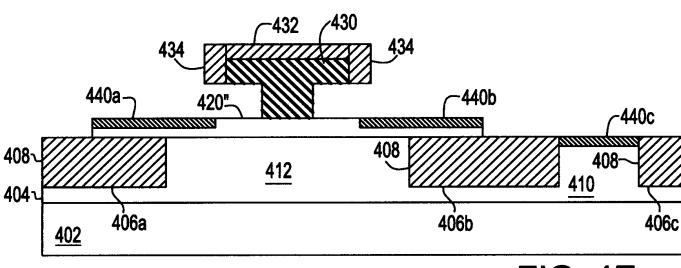
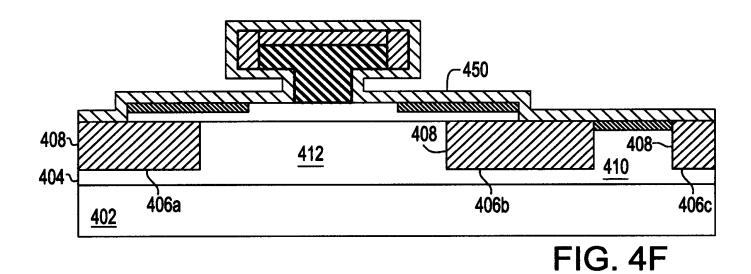
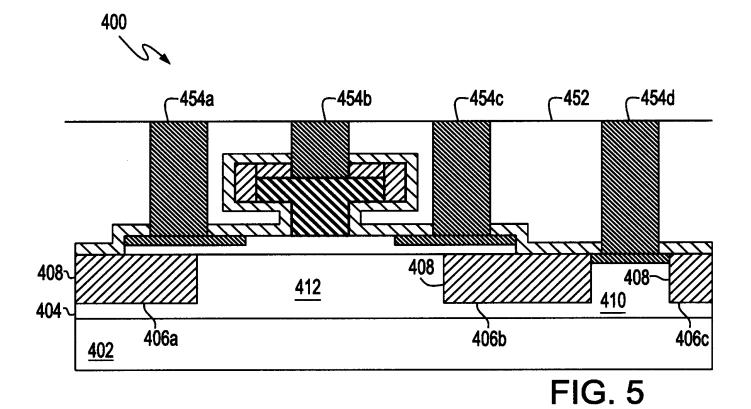
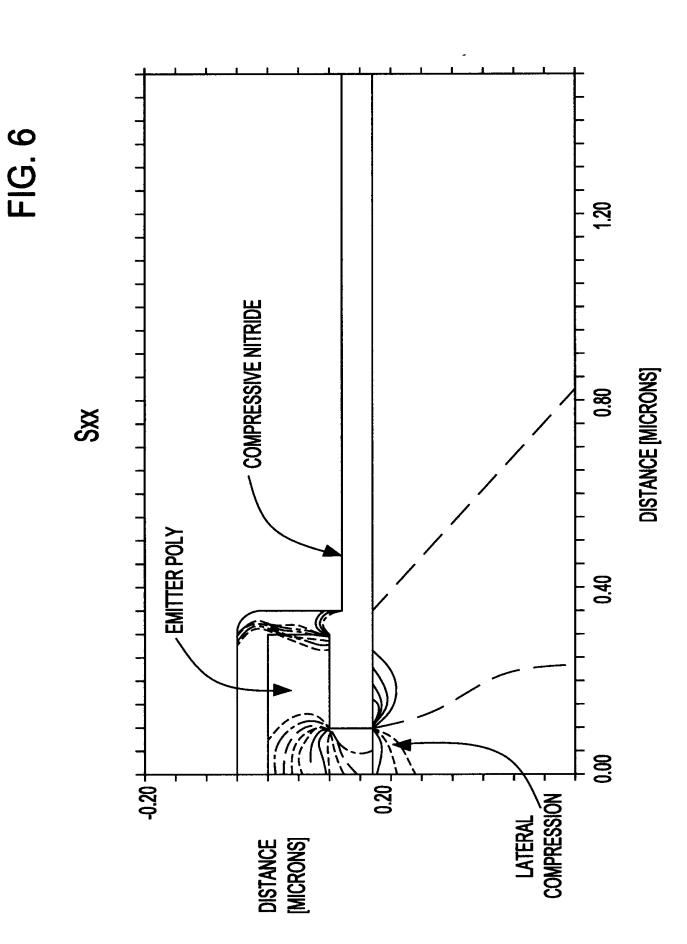
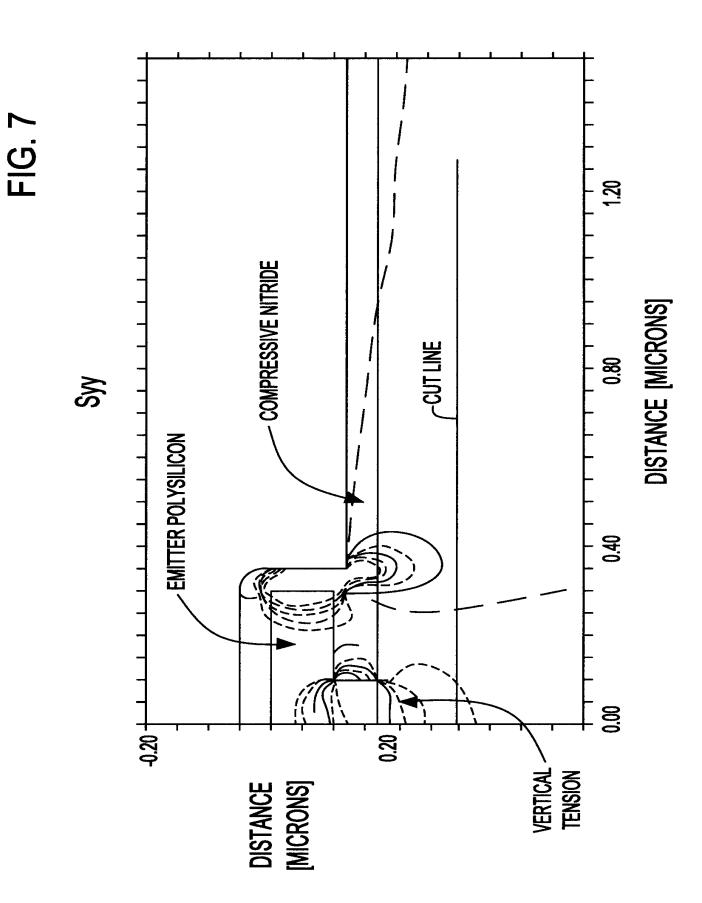


FIG. 4E

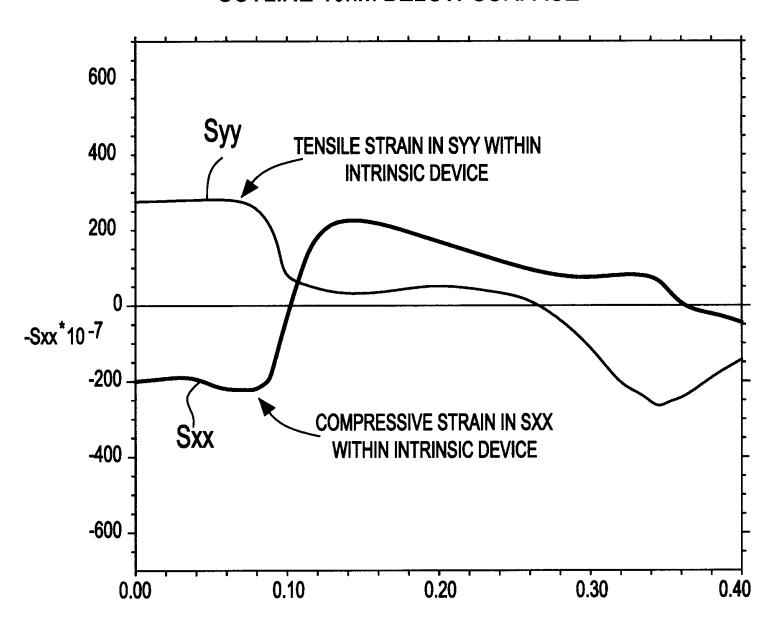








## **CUTLINE 10nm BELOW SURFACE**



**DISTANCE [MICRONS]** 

FIG. 8